



## UNITED STATES PATENT AND TRADEMARK OFFICE

UNITED STATES DEPARTMENT OF COMMERCE  
 United States Patent and Trademark Office  
 Address: COMMISSIONER FOR PATENTS  
 P.O. Box 1450  
 Alexandria, Virginia 22313-1450  
 www.uspto.gov

## \*BIBDATASHEET\*

CONFIRMATION NO. 8916

Bib Data Sheet

SERIAL NUMBER 10/774,489	FILING DATE 02/10/2004  RULE	CLASS 216	GROUP ART UNIT 1763	ATTORNEY DOCKET NO. 2004_0208
-----------------------------	---------------------------------------	--------------	------------------------	-------------------------------------

APPLICANTS

Hiroshi Sotozaki, Tokyo, JAPAN;  
 Koji Ato, Tokyo, JAPAN;

\*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of 10/283,154 10/30/2002 ABN  
 which is a DIV of 09/434,482 11/05/1999 PAT 6,494,985

*dm*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

JAPAN 10-316522 11/06/1998  
 JAPAN 11-138705 05/19/1999  
 JAPAN 11-236776 08/24/1999

*dm*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 05/06/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY JAPAN	SHEETS DRAWING 10	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 1
---	--	------------------------------	-------------------------	-----------------------	----------------------------

Verified and Acknowledged

*Michael A. ...*  
 Examiner's Signature Initials

ADDRESS

000513  
 WENDEROTH, LIND & PONACK, L.L.P.  
 2033 K STREET N. W.  
 SUITE 800  
 WASHINGTON , DC  
 20006-1021

TITLE

Method and apparatus for polishing a substrate

☐ All Fees